Front Matter: Volume 10837


Event: Ninth International Symposium on Advanced Optical Manufacturing and Testing Technologies (AOMATT2018), 2018, Chengdu, China
9th International Symposium on Advanced Optical Manufacturing and Testing Technologies

Large Mirrors and Telescopes

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26–29 June 2018
Chengdu, China

Organized by
Institute of Optics and Electronics, Chinese Academy of Sciences (China)

Sponsored by
COS—The Chinese Optical Society (China)
IOE—Institute of Optics and Electronics, Chinese Academy of Sciences (China)

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Volume 10837
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Please use the following format to cite material from these proceedings:


ISSN: 0277-786X
ISSN: 1996-756X (electronic)
ISBN: 9781510623163

Published by
SPIE
P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445
SPIE.org
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